## Opening

<table>
<thead>
<tr>
<th>Time</th>
<th>Event</th>
<th>Speaker/Position</th>
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| 13:00-13:10 | Opening remarks              | Prof. Sunao Ishihara
Representative of EUV-FEL Light Source Study Group for Industrialization |
| 13:10-13:15 | Greeting                     | Dr. Tetsuyuki Muramatsu
MEXT                                                                 |
| 13:15-13:25 | Target of the workshop       | Prof. Hiroshi Kawata
KEK (Secretary of the Workshop)                                  |

## Keynote Lecture

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<thead>
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<th>Time</th>
<th>Topic</th>
<th>Speaker/Institution</th>
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Rapidus Corporation                                                          |

## Invited Talk

<table>
<thead>
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<th>Time</th>
<th>Topic</th>
<th>Speaker/Institution</th>
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| 14:05-14:35 | The Last Light Source                                                 | Dr. Erik R. Hosler
xLight, Inc.                                                               |
| 14:35-15:05 | Overview of accelerator element development in KEK for realization of EUV-FEL | Prof. Shinichiro Michizono
Accelerator Laboratory, KEK                                                |
| 15:05-15:20 | Break                                                                |                                                                         |
| 15:20-15:50 | The importance of and methods for coherence reduction in accelerator based lithography systems | Dr. Patrick P. Naulleau
EUV Tech Inc.,
Lawrence Berkeley National Laboratory                                      |
| 15:50-16:20 | The current status and difficulties in manufacturing multilayer mirrors for BEUV lithography | Dr. Hisataka Takenaka
TOYAMA Co., Ltd.                                                             |
Quantum and Photonics Technology Research Center, Kyushu University        |

## Closing address & Photo-session

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<thead>
<tr>
<th>Time</th>
<th>Event</th>
<th>Speaker/Position</th>
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| 16:50-17:00 | Closing address                | Koki Uchimaru
KEK, Executive Director                                                          |